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CONFIRMATION NO. 5289

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| SERIAL NUMBER 10/533,147 | FILING OR 371(c) DATE 04/27/2005 RULE | CLASS 117 | GROUP ART UNIT 1722 | ATTORNEY DOCKET NO. 94198 |
| APPLICANTS Susumu Maeda, Kanagawa, JAPAN; Hiroshi Inagaki, Kanagawa, JAPAN; Shigeki Kawashima, Kanagawa, JAPAN; Shoei Kurosaka, Kanagawa, JAPAN; Kozo Nakamura, Kanagawa, JAPAN; | | | | |
| ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/14001 10/31/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-317955 10/31/2002 | | | | |
| Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged <i>S.M. Maeda</i> Examiner's Signature Initials | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 6 | TOTAL CLAIMS 10 |
| | | | INDEPENDENT CLAIMS 3 | |
| ADDRESS 24628 | | | | |
| TITLE Method for producing silicon wafer | | | | |
| FILING FEE RECEIVED 1000 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | |